

Recent progress in large tunnel magnetoresistance junctions

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1. A little review of MTJs

2. Heusler electrode TMR junctions

- Relationship between degree of order and TMR ratio
- Temperature and bias dependences of TMR ratio

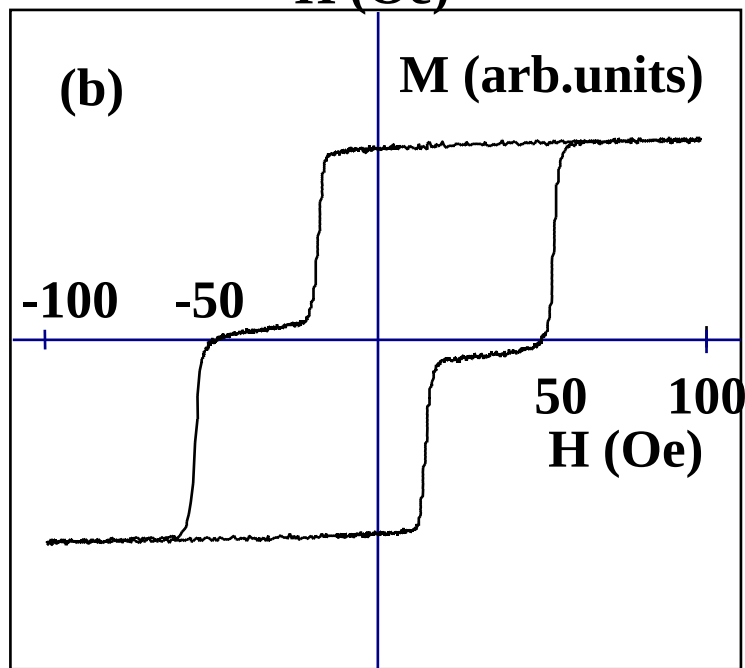
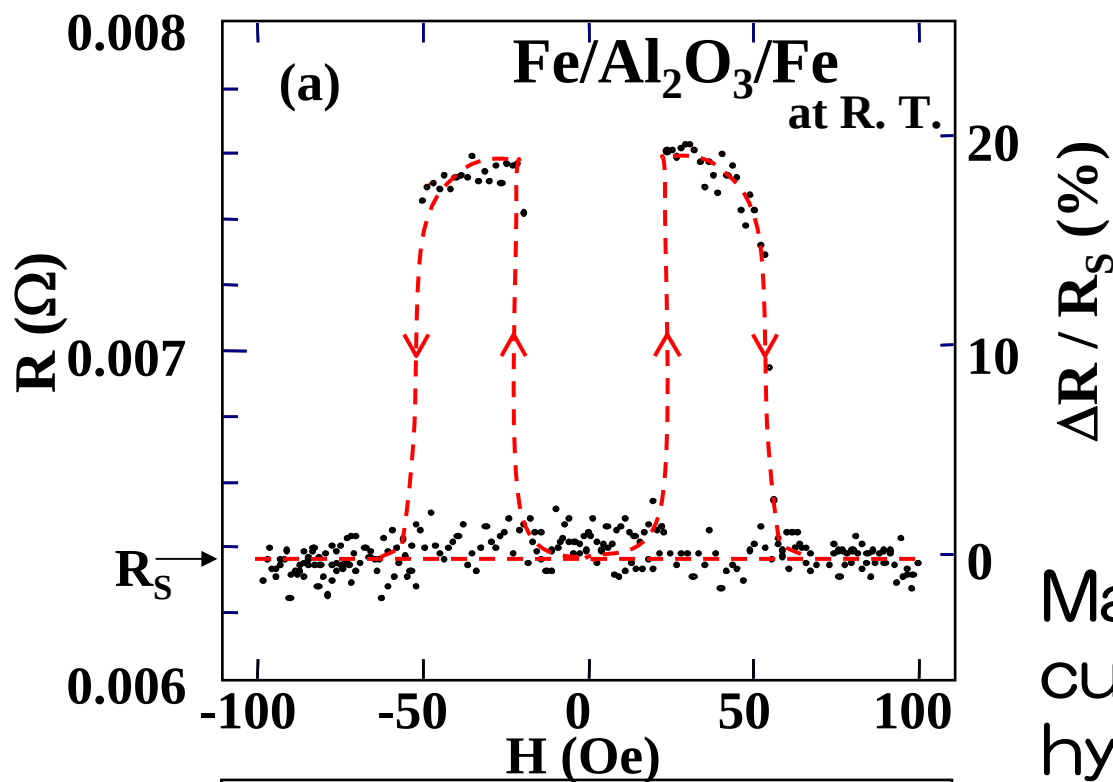
3. Applications of TMR junctions (Gilbert damping constant α)

1. A little review of MTJs

History of TMR research

(Typical reports)

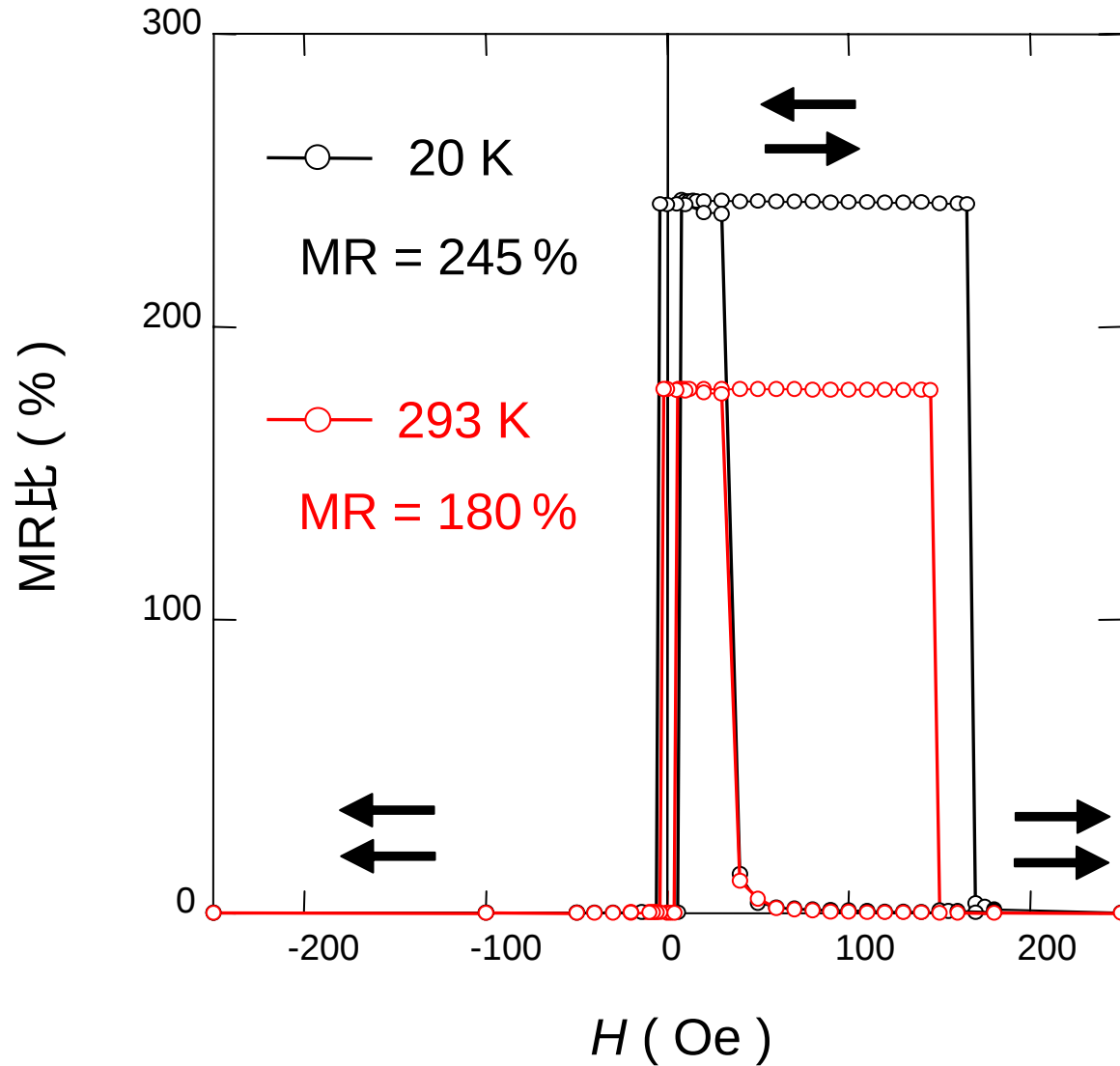
- Julliere (Phys. Lett., **54A**,225(1975)) Gd-O
- T.Miyazaki et al. (J.Magn.Magn.Mater.139,**L231**(1995)) Al-O
- J.S.Moodera et al. (Phys.Rev.Lett., **74**, 3273(1995)) Al-O
-
- S.Yuasa et al. (Jpn.J.Appl.Phys., **43**, L588(2004)) MgO
- S.S.P.Parkin et al. (Nature Materials, **3**, 863(2004)) MgO
-
- Y.Sakuraba et al. (Appl.Phys.Lett., **88**, 192508(2006)) Heusler
- N.Tezuka et al. (Appl.Phys. Lett.,**89**, 252508-1(2006)) Heusler
- T.Ishikawa et al. (Appl.Phys.Lett.,**89**,192505-1(2006)) Heusler



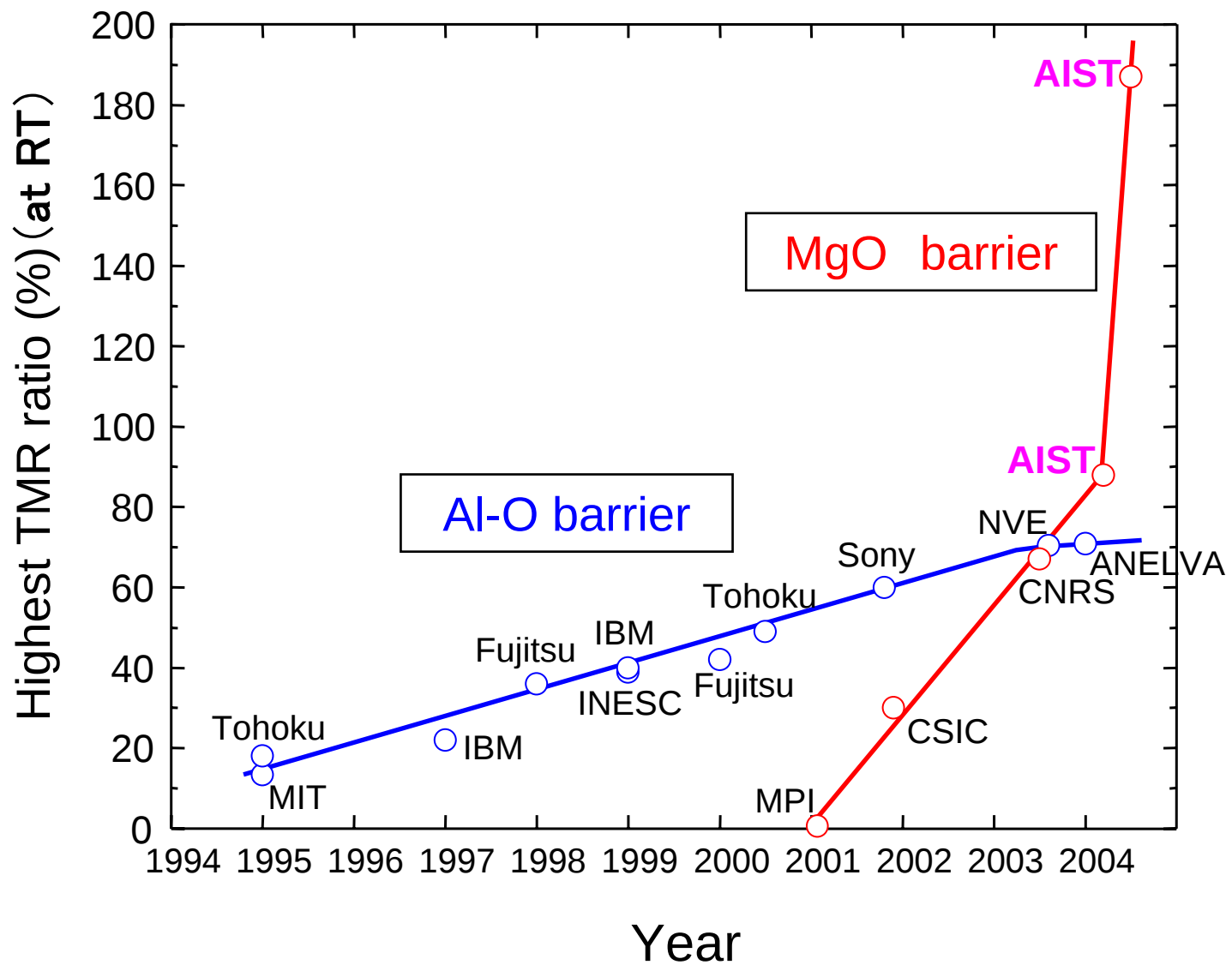
Magnetoresistance curve (a) and magnetic hysteresis loop (b) for Fe/Al₂O₃/Fe junction

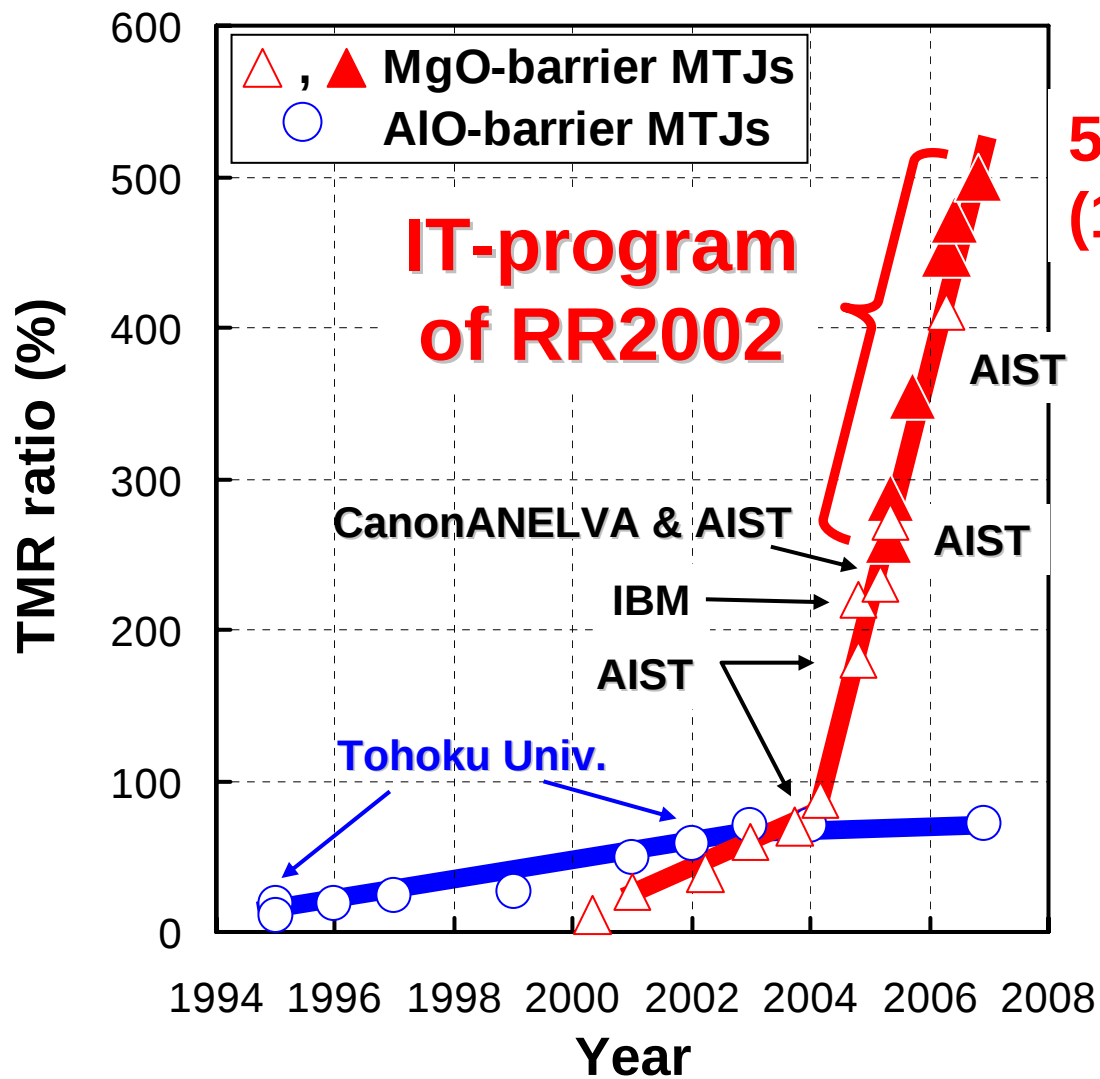
T.Miyazaki and N.Tezuka, J.3M,
139,L2341(1995).

Fe(001)/MgO(001)/Fe(001)



Yuasa et al. Nature Materials 3 (2004).





2. TMR in Heusler alloy electrode junction

***Kristallstruktur und Ferromagnetismus der Mangan-Aluminium-Kupferlegierungen*¹⁾**

Von Otto Heusler

(Mit 20 Figuren)

Inhalt: A. Problemstellung. — B. Experimentelles. — C. Röntgenographische Strukturbestimmung. — D. Messungen des elektrischen Widerstandes. — E. Magnetische Messungen. — F. Versuch zu einer Deutung des Ergebnisses. — G. Zusammenfassung.

A. Problemstellung

Seit es Heisenberg²⁾ gelungen ist, eine quantenmechanische Deutung des Ferromagnetismus zu geben, ist der Zusammenhang zwischen Kristallstruktur und Ferromagnetismus zu einem entscheidenden Problem für den weiteren Ausbau der Theorie geworden. Denn Heisenberg zeigte, daß neben der Elektronenkonfiguration der beteiligten Atome in erster Linie die Kristallstruktur maßgebend für das Zustandekommen dieser Erscheinung ist. Welcher Art diese strukturellen Vorbedingungen im einzelnen sind, ist bislang noch nicht hinreichend erfaßt. Es ist daher eine wichtige Aufgabe, diese Frage auf experimentellem Wege anzugreifen. In diesem Zusammenhang dürfen die an der Grenze des ferromagnetischen Erscheinungsgebiets stehenden Heuslerschen Legierungen, die aus unmagnetischen Komponenten aufgebaut sind, einiges Interesse beanspruchen.

Besonders wichtig sind hier die sogenannten Alterungserscheinungen, die schon von Anfang an die Aufmerksamkeit der Forscher auf sich lenkten: Offenbar ganz geringfügige Änderungen der Kristallstruktur, die sich durch thermische

1) Der erste Teil der vorliegenden Arbeit (röntgenographische Strukturbestimmung) wurde am 28. Januar 1933 in der Sitzung des Gauvereins Hessen der D. Phys. Ges. in Darmstadt vorgetragen (Referat Verh. D. Phys. Ges. [3] 14. S. 7. 1933), der zweite Teil (elektrische und magnetische Messungen) am 27. Mai 1933 auf der Tagung der D. Bunsengesellschaft in Karlsruhe (Referat Ztschr. Elektrochem. 39. S. 645. 1933).

2) W. Heisenberg, Ztschr. f. Phys. 49. S. 619. 1928.

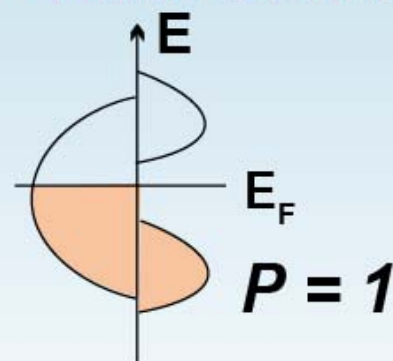
**Annalen der Physik Band
19 (1934) 155-201.**

Functions of Heusler Compounds

1905	• Magnetic material:	Cu_2MnAl	
1983	• Halfmetallic ferromagnet:	NiMnSb	
	• Magneto-optical:	PtMnSb	
	• Magneto-mechanic:	Ni_2MnGa	
	• Superconductor:	Pd_2YSn	
	• Semiconductor:	CoTiSb	From Prof. Felser
	• Heavy fermion:	Fe_2VAl	
	• Li-conductor:	LiMnSb	
2001	• Magneto-electronic:	Co_2FeSi	
	• Thermo-electric:	TiNiSn	
	• Magneto-caloric:	CoMnSb:Nb	
	- Spintronics Material :	Co_2MnSi	

MTJs with Half-metallic electrode

- Half-metals (Heusler alloys, $\text{La}_{2/3}\text{Sr}_{1/3}\text{MnO}_3$, Fe_3O_4 etc.)



LSMO/STO/LSMO MR ~ 0 % (RT), 1800% (4 K)

LSMO $T_c = 370$ K

$P = 0.95$

M. Bowen et al. Appl. Phys. Lett. 82 (2003) 233

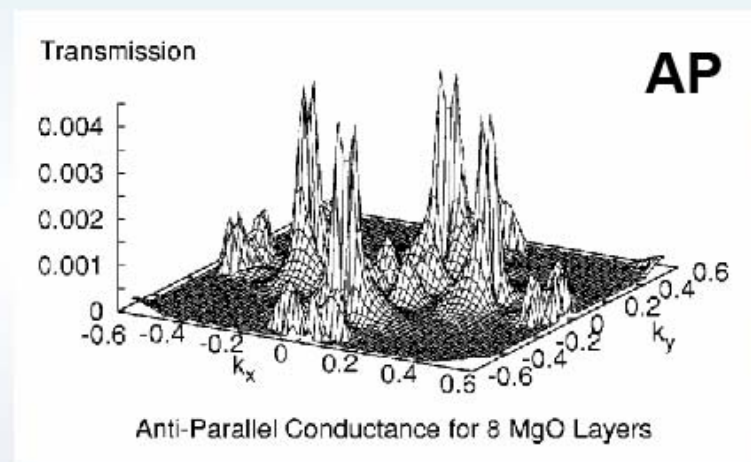
Fe/MgO/Fe,CoFeB/MgO/CoFeB-MTJ

Finite tunnel conductance in AP

$\Rightarrow P < 1$, Maximum TMR ~ 1200%

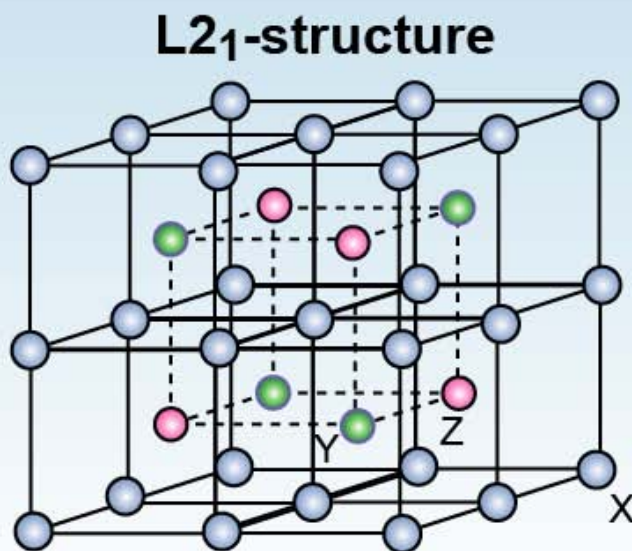
Butler et al. PRB 63 056614 (2001)

Mathon & Umerski PRB 63 220403 (2001)

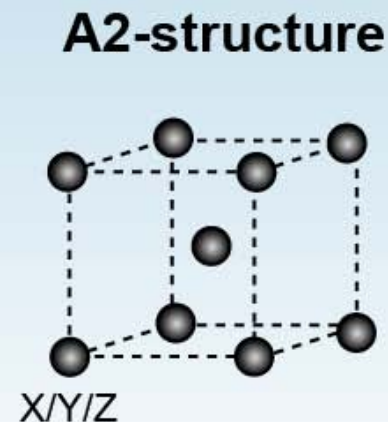
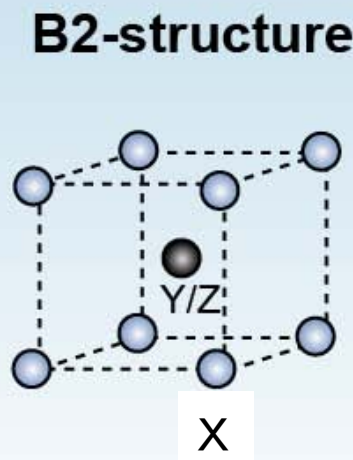


Half-metallic full-Heusler alloys : Co_2MnSi , Co_2MnGe , etc.

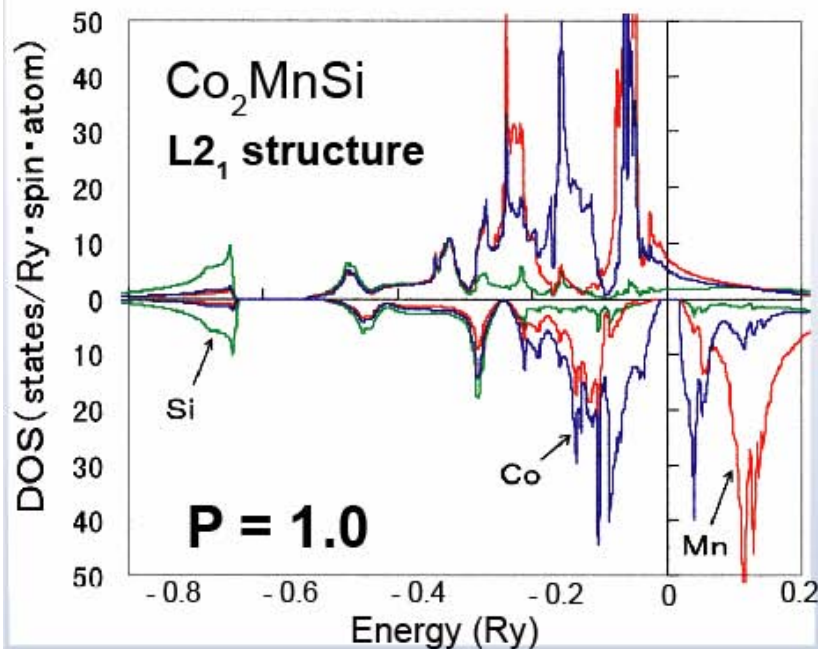
- ★ High T_c well above RT $\Rightarrow$ large spin-polarization even at RT
- ★ High spin injection efficiency g , Small damping constant α
 $\Rightarrow$ reduce J_c in spin-transfer switching



Ordered-state



Disordered-state



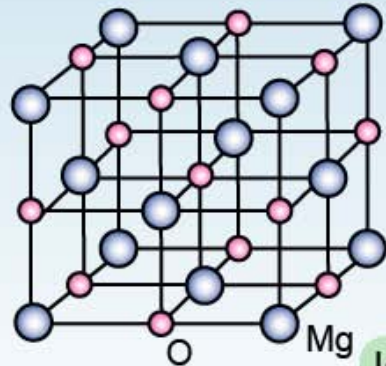
Co₂MnSi (CMS)

- Half-metallic band gap : 400 - 600 meV
- L₂₁-structure is easily obtained by annealing process
- High T_C (~ 985 K)

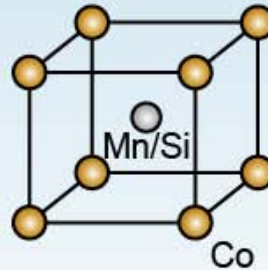
$\Rightarrow$ *Co₂MnSi is expected as the most promising HMF*

Introduction - Epitaxial relation between MgO and Co_2MnSi -

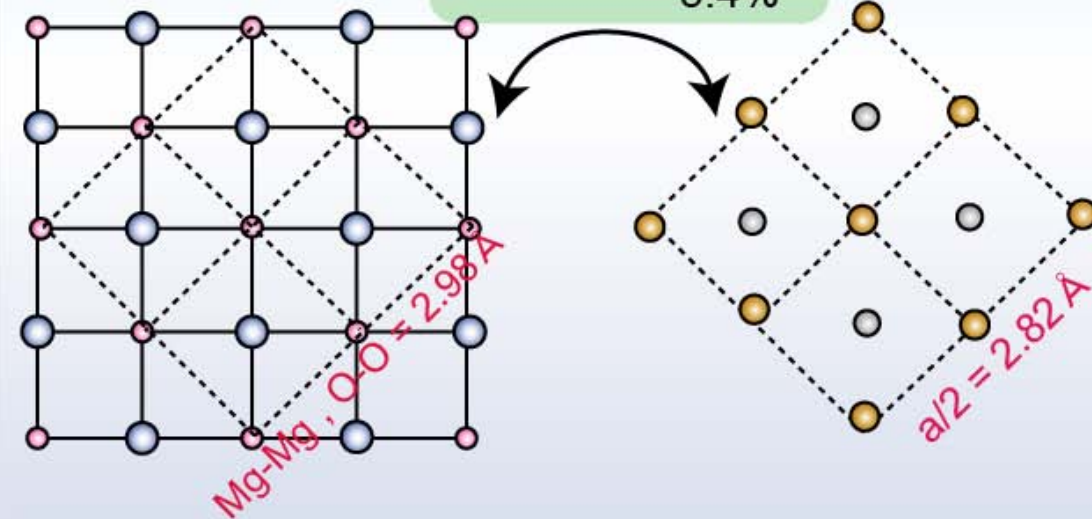
MgO (NaCl-type)
 $a = 4.22 \text{ \AA}$



Co_2MnSi
 $a = 5.65 \text{ \AA}$

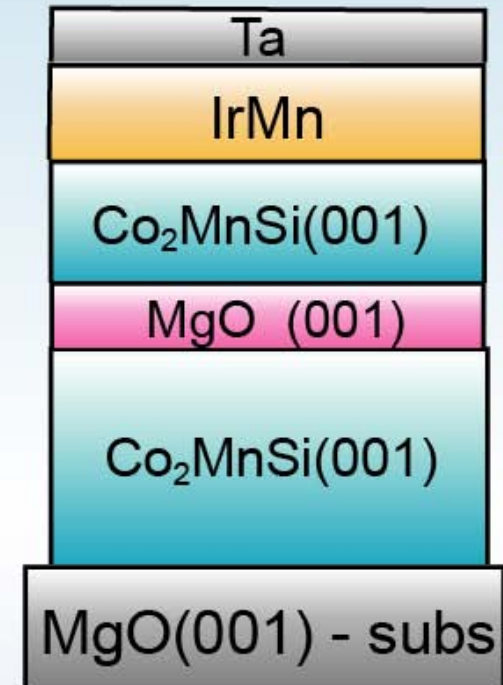


lattice mismatching
 $= 5.4\%$



Epitaxial relation:

$\text{Co}_2\text{MnSi}(001)[100] // \text{MgO}(001)[110]$



Full-epitaxial MTJ can be fabricated on $\text{MgO}(001)$ single crystalline substrate.

Experimental method

UHV magnetron sputtering system ($P < 1 \times 10^{-7} \text{Pa}$)

MTJ Al-O barrier : O_2 plasma oxidation of Al layer
MgO barrier : rf-sputtering from MgO target
micro-fabrication : photolithography & Ar ion milling
(element size : $5 \times 5 \sim 100 \times 100 \mu\text{m}^2$)
Annealing : $200 - 300^\circ\text{C}$ at 300 Oe
MR, I-V curve : DC 4-probe method
G-V curve : AC lock-in amplifier technique

Co_2MnSi bottom epitaxial electrode

Target : $\text{Co}_{2.00}\text{Mn}_{1.28}\text{Si}_{1.30} \Rightarrow \text{Film} : \text{Co}_{2.00}\text{Mn}_{1.00}\text{Si}_{1.08}$ (ICP)

Deposited @ RT $\Rightarrow$ Post-annealed : $T_a = 250 - 650^\circ\text{C}$

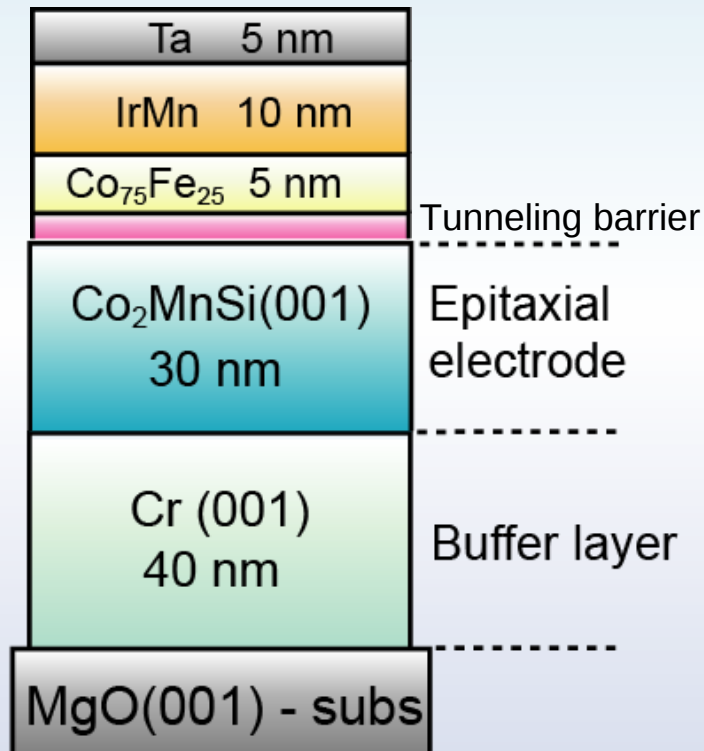
Crystal structure, $\text{L2}_1 \cdot \text{B2}$ ordered level : XRD

Magnetization : SQUID

Surface image : AFM

Cr buffer layer

Substrate temp : T_s , Post-annealing temp : T_{ann}



Stacking structure

Result 1

- *Epitaxial bottom Co_2MnSi electrode* -

XRD (θ - 2θ scan)

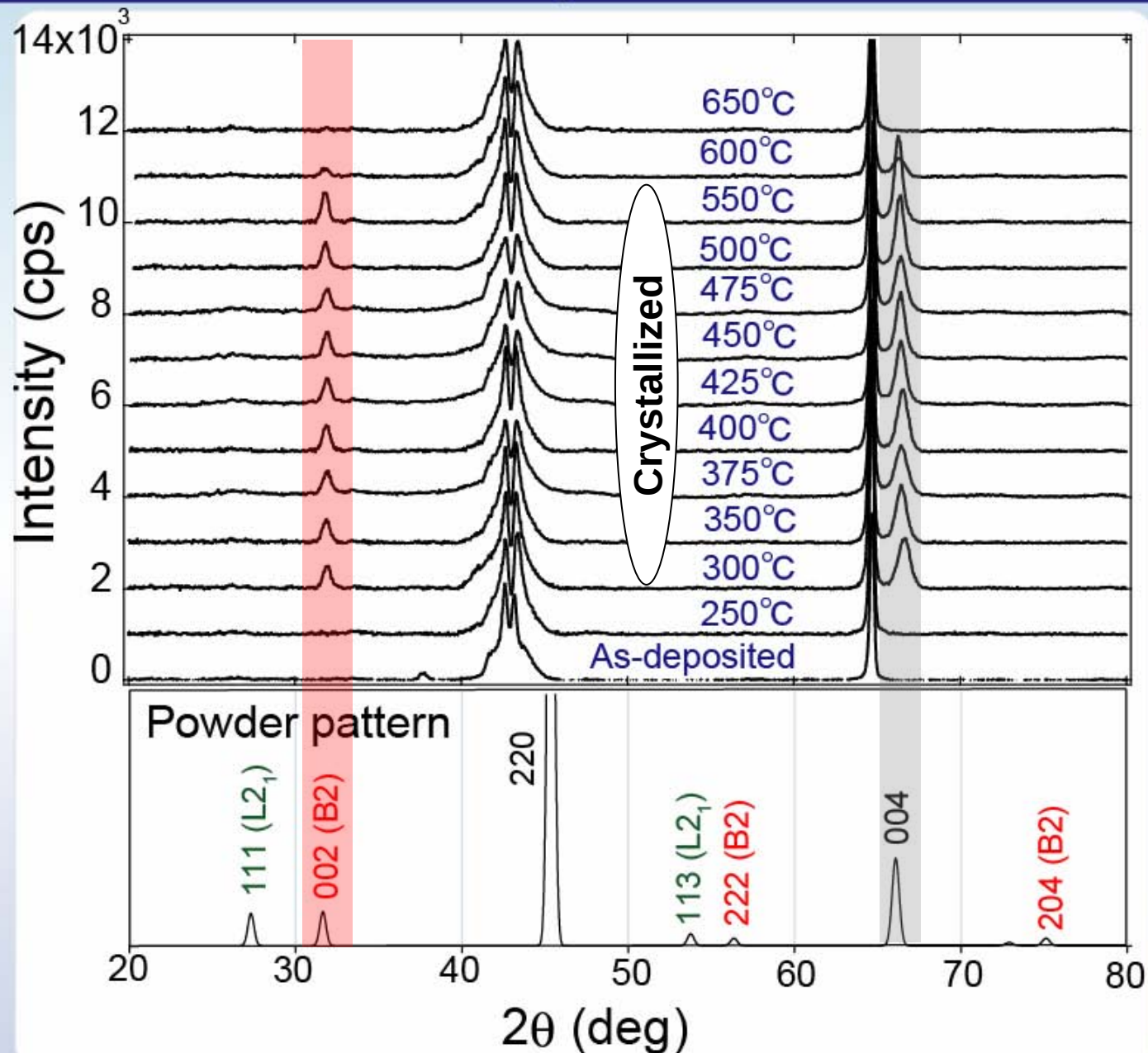
- Superlattice peaks

L2_1 -structure
 h, k, l : all odds

B2-structure
 $h+k+l = 4n+2$

- Fundamental peaks

A2-structure
 $h+k+l = 4n$

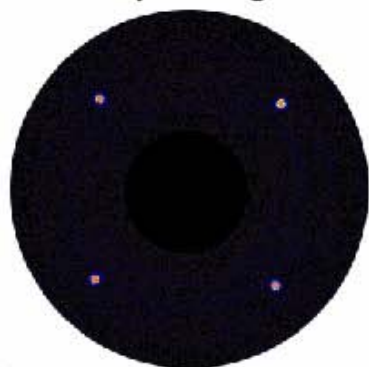


Result 1

- Epitaxial bottom Co_2MnSi electrode -

L2₁-order: I(111)/I(220)

220 pole-figure



111 pole-figure



BRUKER DISCOVER D8 / 2 dimensional detector

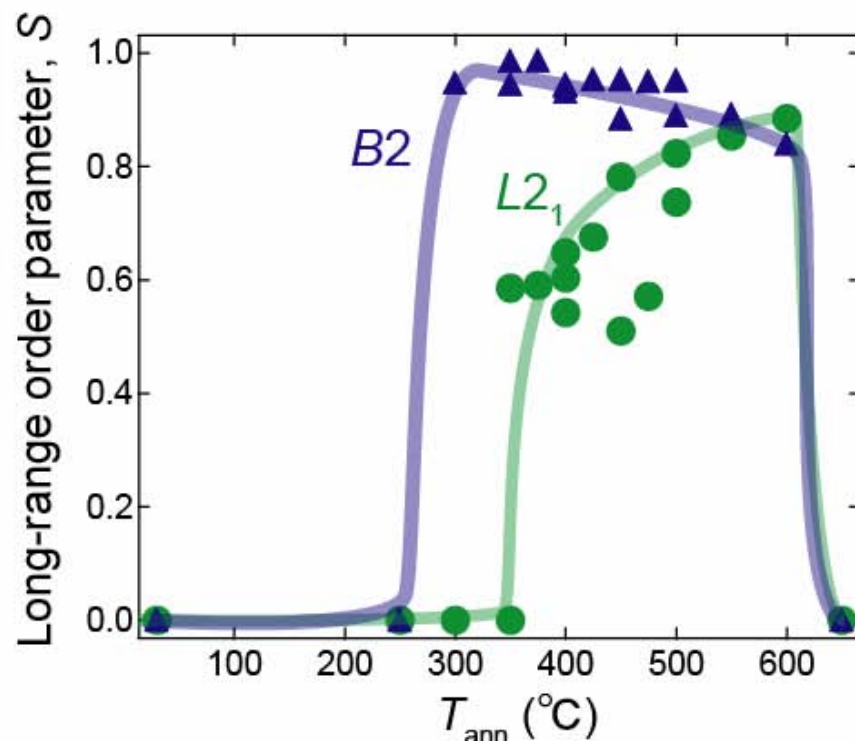
Long-range order parameter, S

$$S_{B2}^2 = \frac{I_{\text{obs}}(200)/I_{\text{obs}}(400)}{I_{\text{cal}}(200)/I_{\text{cal}}(400)}$$

$$S_{L2_1}^2 = \frac{I_{\text{obs}}(111)/I_{\text{obs}}(220)}{I_{\text{cal}}(111)/I_{\text{cal}}(220)}$$

$$I_{\text{cal}} = I_{\text{sim}} \cdot \underbrace{m^{-1}}_{\text{multiple factor}} \cdot \underbrace{G_t}_{\text{Film thickness factor}}$$

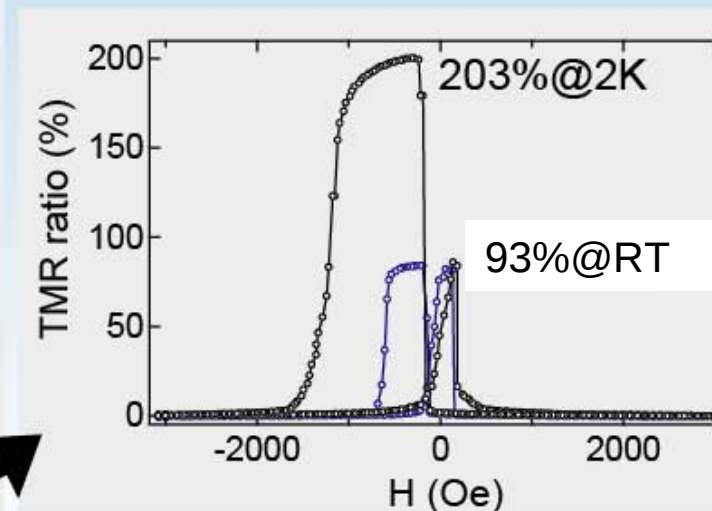
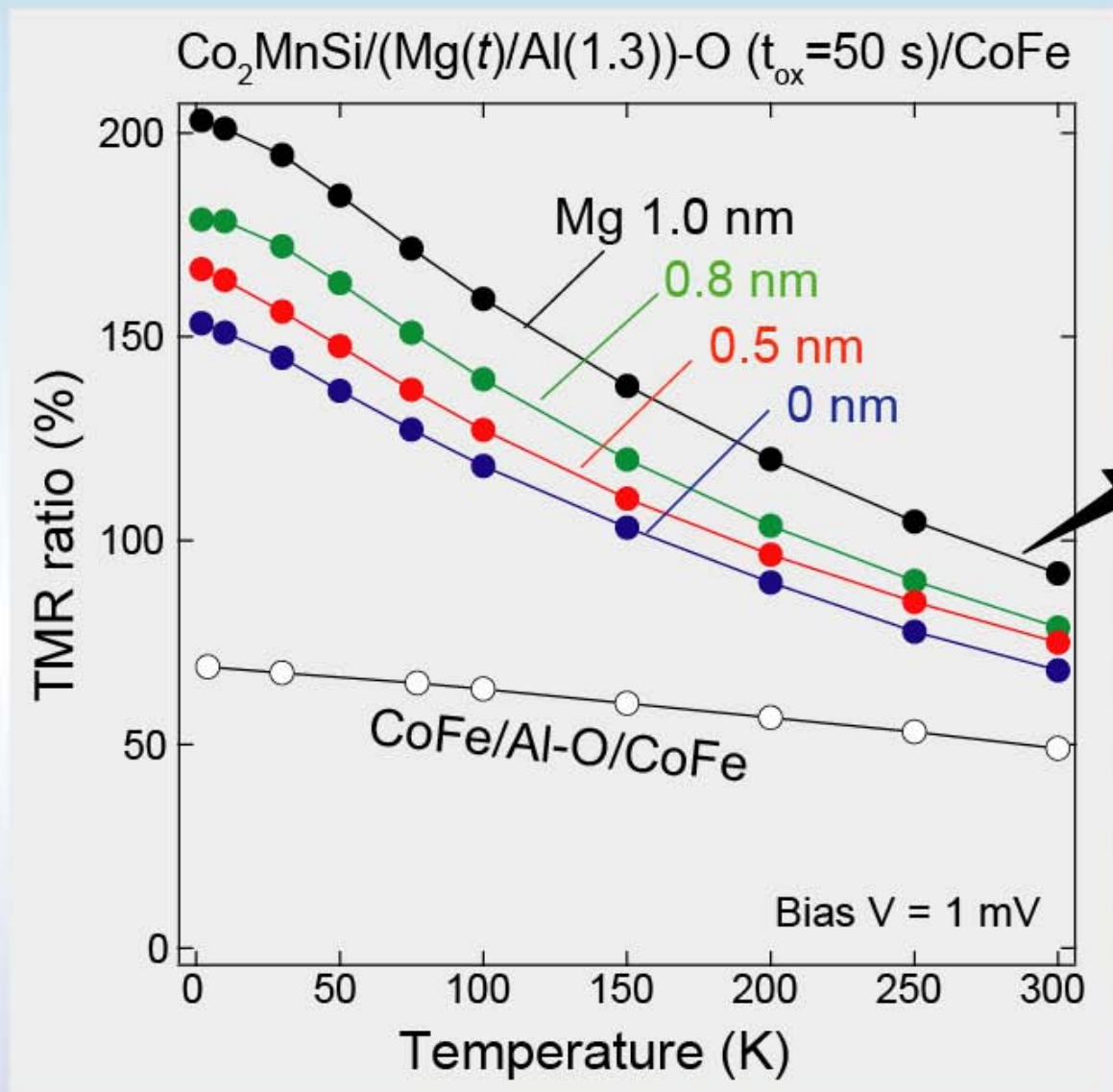
$$G_t = 1 - \exp\left(\frac{-2\mu t}{\sin\theta}\right)$$



B2-order : $T_{\text{ann}} > 300^\circ\text{C}$, $S \sim 1$
L2₁-order : $T_{\text{ann}} = 600^\circ\text{C}$, $S \sim 0.9$

We successfully fabricated highly ordered Co_2MnSi

Sakuraba et al. Jpn. J. Appl. Phys. 44 6536 (2005)



CMS/(Mg/Al)-O/CoFe

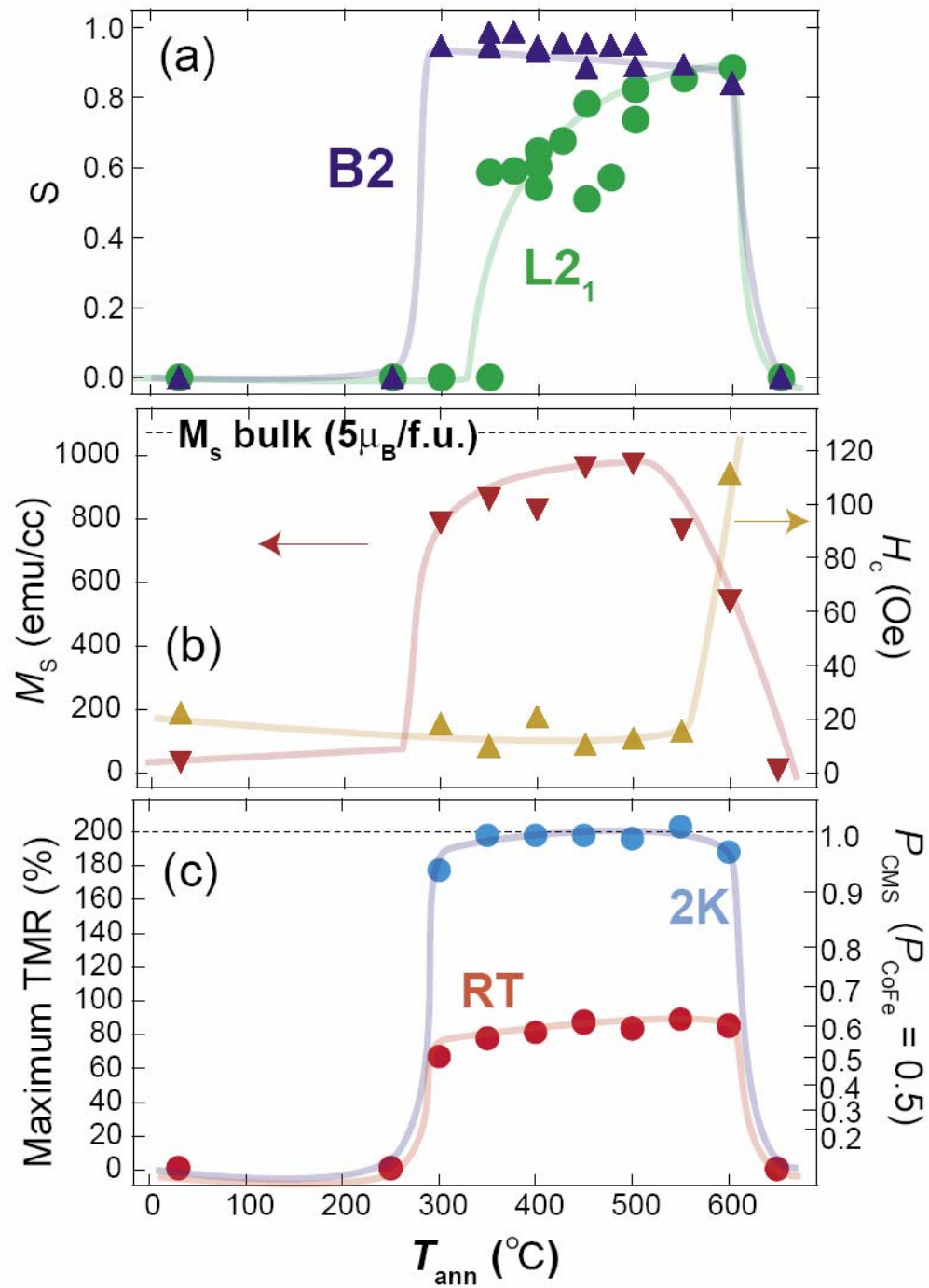
TMR ~ 93% @ RT

~ 203% @ 2K

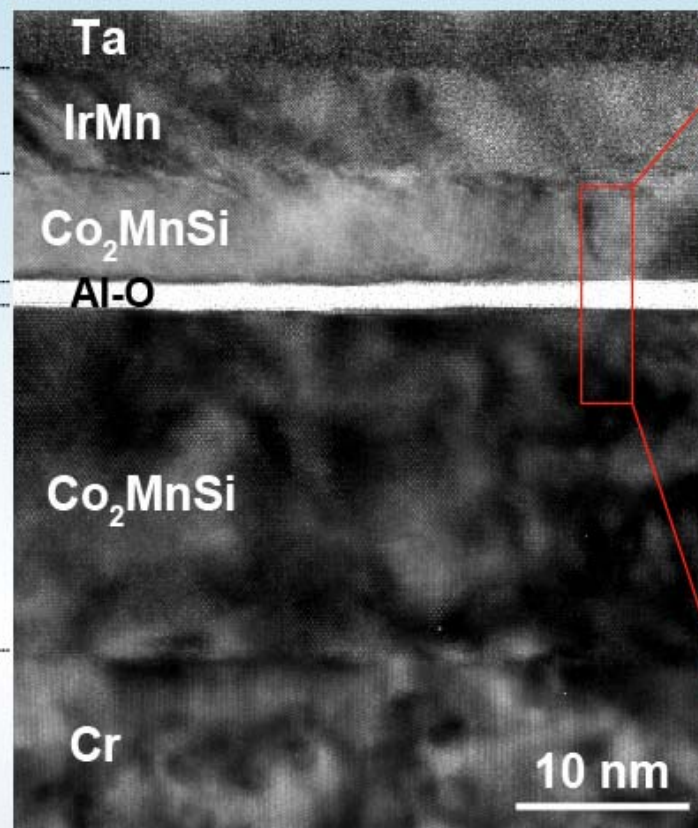
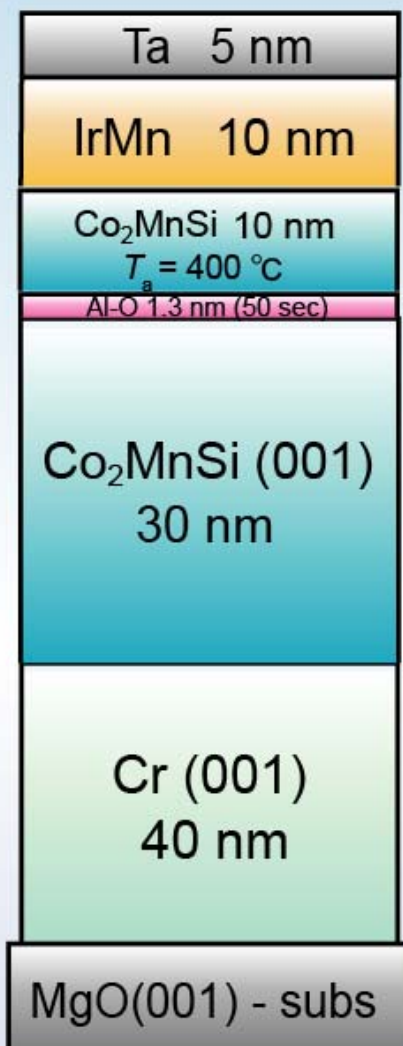
$\Rightarrow \underline{P_{\text{CMS}} \sim 1.0}$ ($P_{\text{CoFe}} \sim 0.50$)

Ideal half-metallic spin-polarization

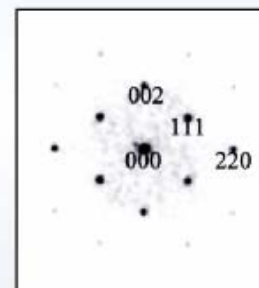
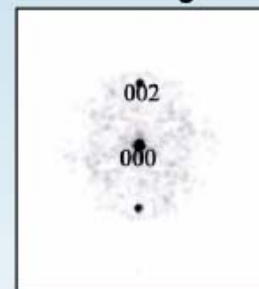
Giant TMR ratio over 1000% at LT is possible in CMS/(Mg/Al/Mg)-O/CMS structure



MTJ - $\text{Co}_2\text{MnSi}/\text{Al-O}/\text{Co}_2\text{MnSi}$



FFT image

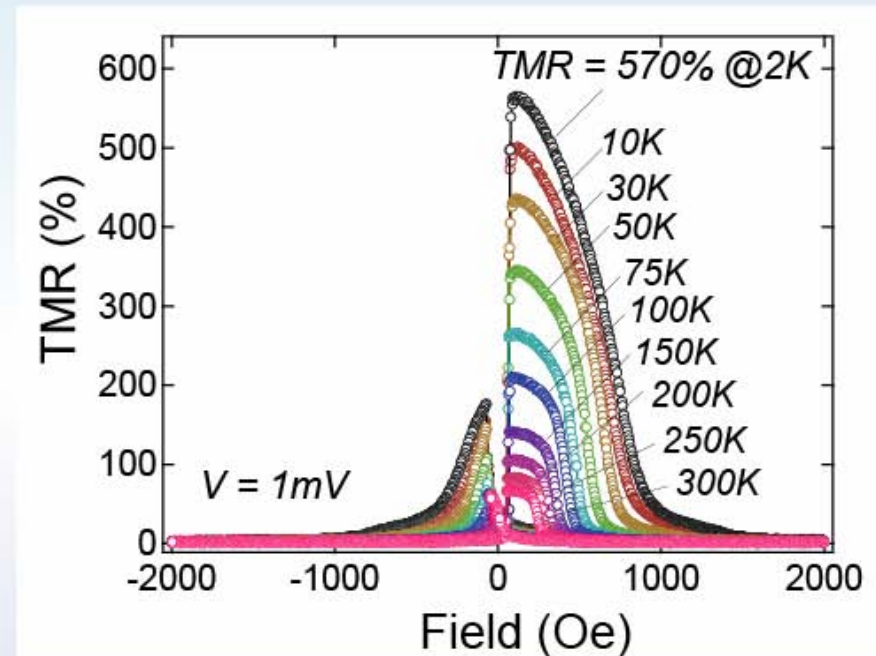
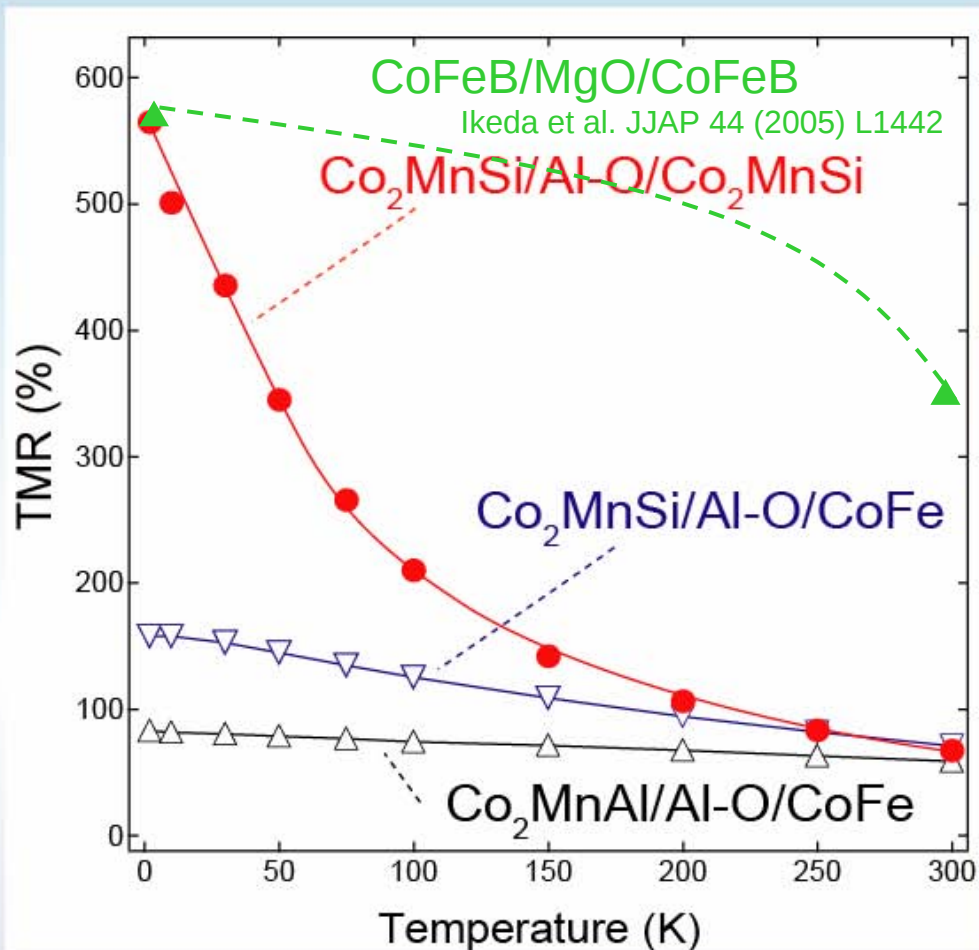


- Upper Co_2MnSi was annealed at 400°C before the deposition of IrMn AF layer.

Junction structure

- Upper Co_2MnSi electrode shows (001)-oriented growth
- Flat and sharp interface around Al-O interface

MTJ - $\text{Co}_2\text{MnSi}/\text{Al-O}/\text{Co}_2\text{MnSi}$



TMR ratio = 67% @ RT, 570% @ 2K

⇒ The largest TMR ratio in MTJ using Al-O barrier

Y. Sakuraba et al. Appl. Phys. Lett. vol.88 192508 (2006)

Large temperature dependence of TMR ratio should be solved.

Non-quasiparticle states in Co_2MnSi evidenced through magnetic tunnel junction spectroscopy measurements

L. Chioncel,^{1,2} Y. Sakuraba,³ E. Arrigoni,¹ M.I. Katsnelson,⁴
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²*Faculty of Science, University of Oradea, RO-410087 Oradea, Romania*

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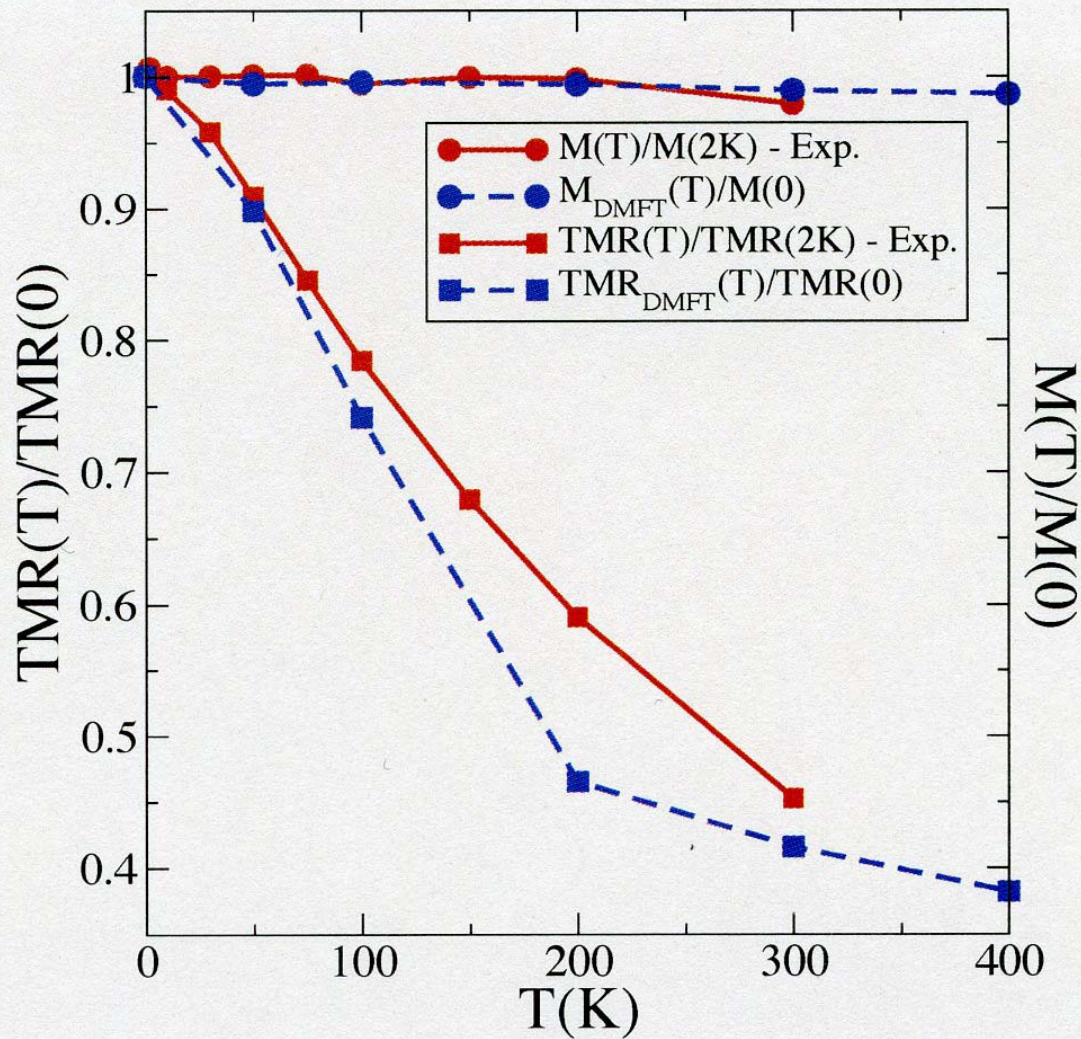
⁴*Institute for Molecules and Materials, Radboud University of Nijmegen, NL-6525 ED Nijmegen, The Netherlands*

⁵*Babeş-Bolyai University, RO-800084 Cluj-Napoca, Romania*

⁶*Institute of Theoretical Physics, University of Hamburg, DE-20355 Hamburg, Germany*

We investigate the effects of electronic correlations in the full-Heusler Co_2MnSi , by combining a theoretical analysis of the spin-resolved density of states with tunneling-conductance spectroscopy measurements using Co_2MnSi as electrode. Both experimental and theoretical results confirm the existence of so-called non-quasiparticle states and their crucial contribution to the finite-temperature spin polarisation in this material.

To be published in Phys. Rev. Lett.



LSDA : Local Spin
Density Appro.

DMFT : Dynamical
Mean Field Theory

FIG. 3: (Color online) Comparison of the TMR ratio and magnetisation (M) as a function of temperature for a FeCo/Al-O/Co₂MnSi tunnel junction as obtained from experimental data and from LSDA+DMFT.

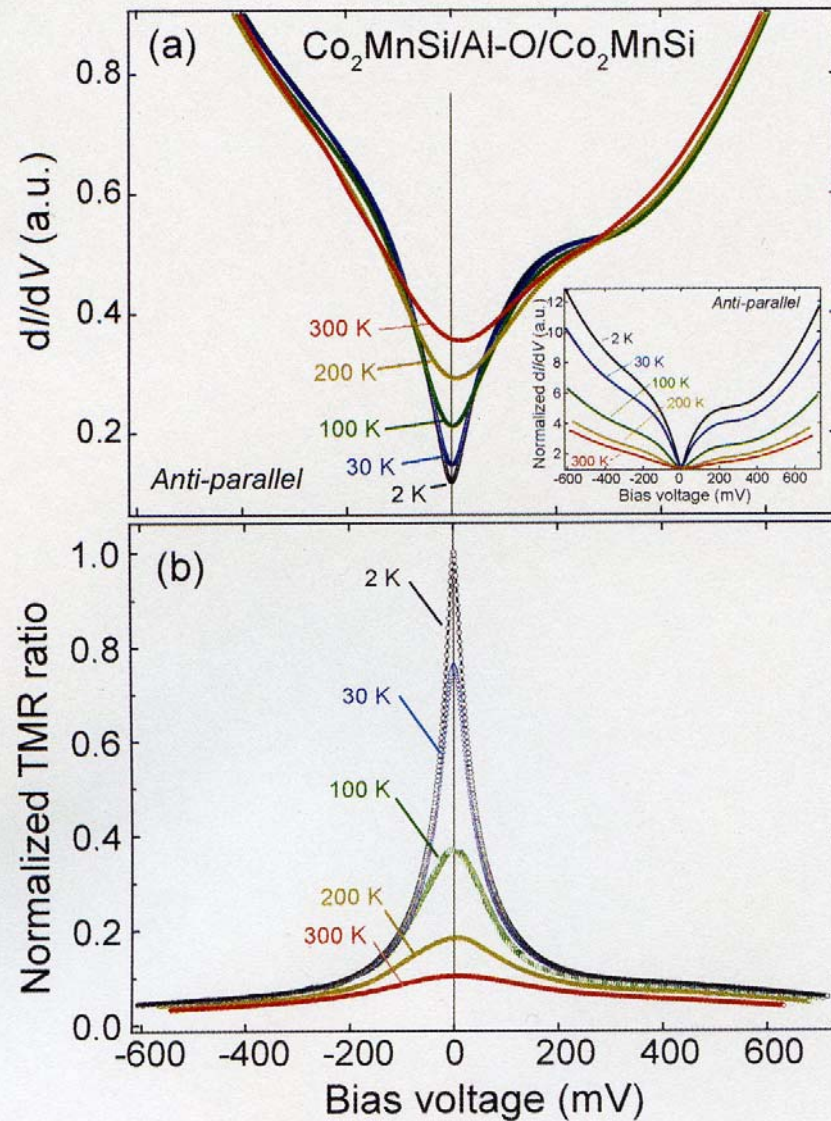


FIG. 2: (Color online) (a) Tunnel conductance for the $\text{Co}_2\text{MnSi}/\text{Al-O}/\text{Co}_2\text{MnSi}$ anti-parallel magnetic tunnel junction and (b) TMR ratio (normalized to $T = 2\text{K}, V = 0$), as a function of voltage for different temperatures. The inset of panel (a) shows the conductance normalized to zero bias voltage.

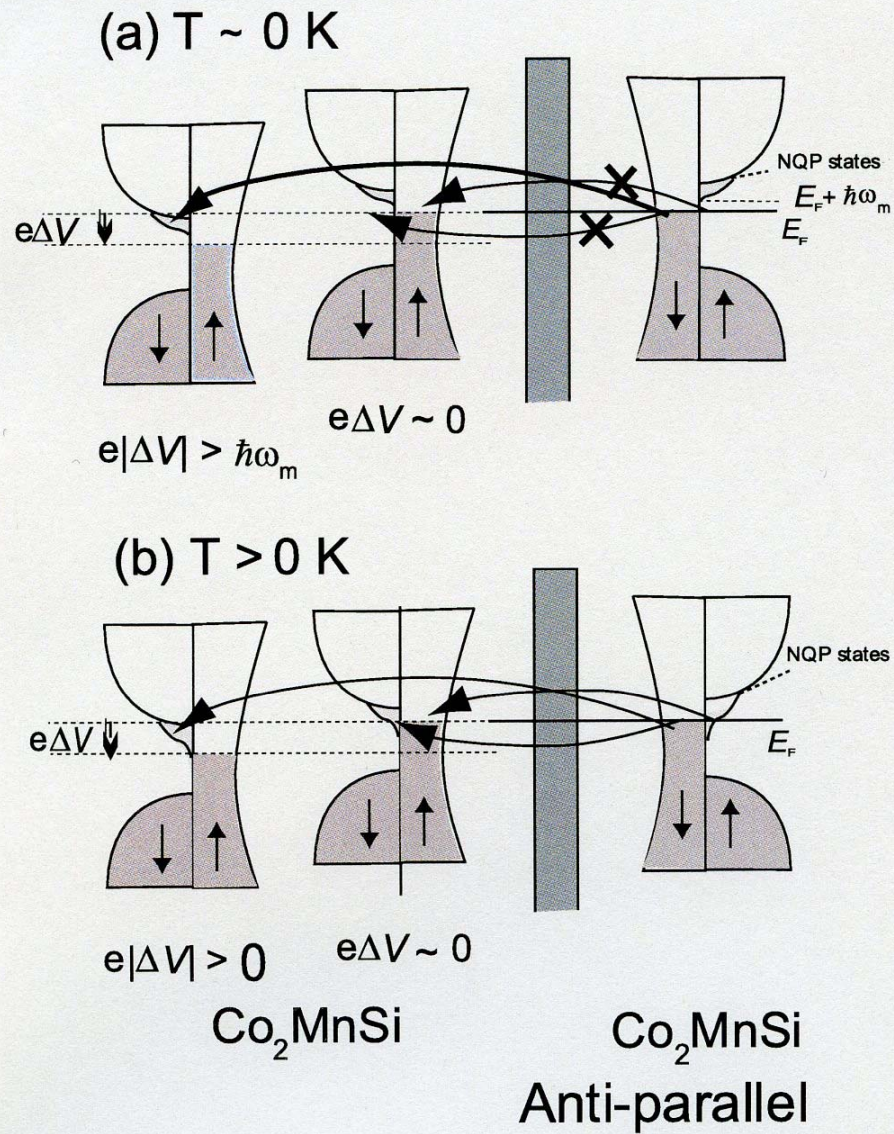


FIG. 4: Schematic representation of an electron tunneling process at $\Delta V \approx 0$ and at finite bias voltage in a $\text{Co}_2\text{MnSi}/\text{Al-O}/\text{Co}_2\text{MnSi}$ magnetic tunnel junction. At $T \approx 0 \text{ K}$ (a), NQP states vanish at E_F , while for $T > 0$ (b) (see text) NQP states extends across E_F and an additional tunneling channel opens.

3. Applications of TMR junction

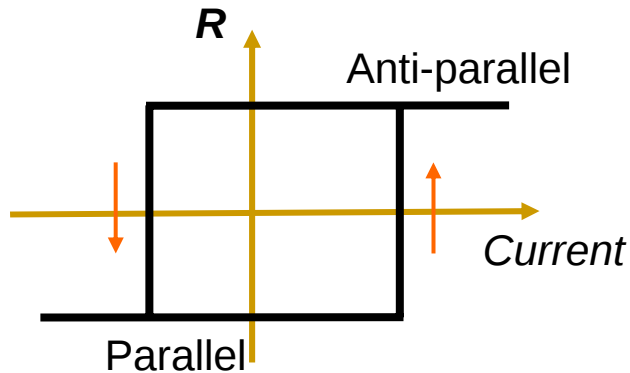
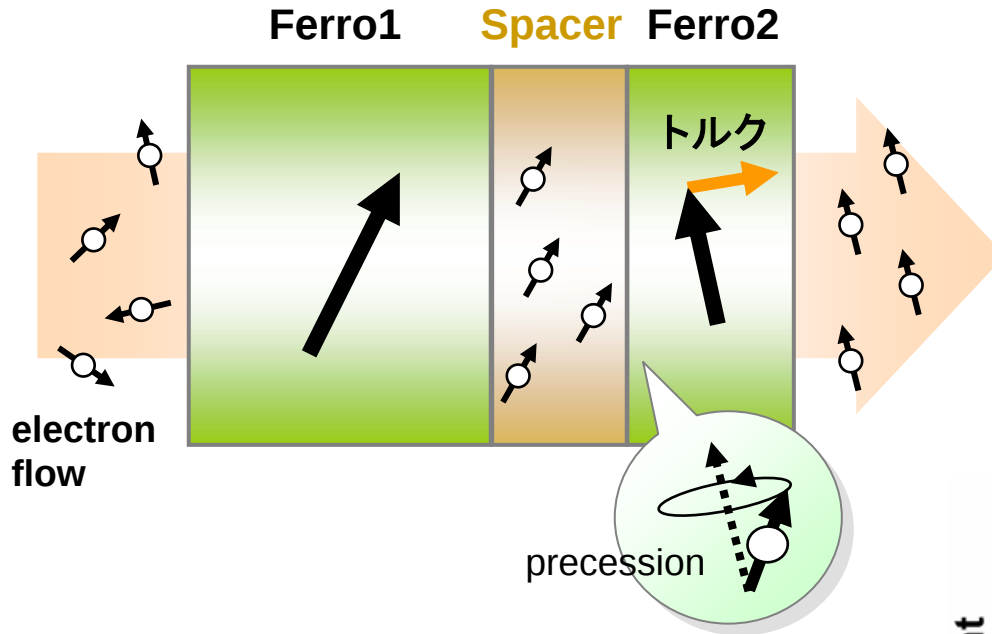
Application of large TMR junctions

- MRA (Magnetization switching : bit and word lines)
- Spin-RAM (Switching by spin transfer torque)
- Magnetic reading head of HDD
- GPS sensor devices
- High frequency oscillator devices
-
-
-

Magnetization switching by direct current

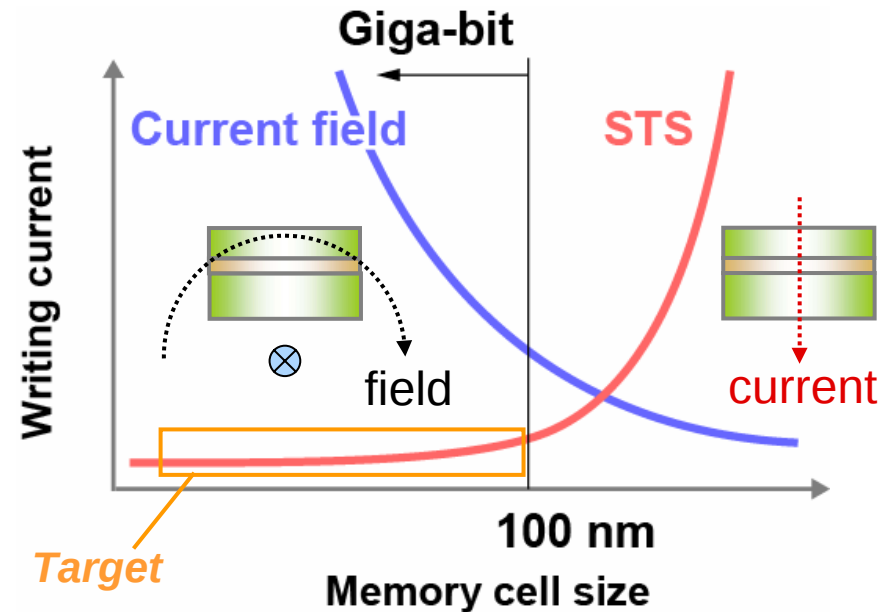
Spin-transfer switching (STS)

Slonczewski, JMMM159 (1996)L1



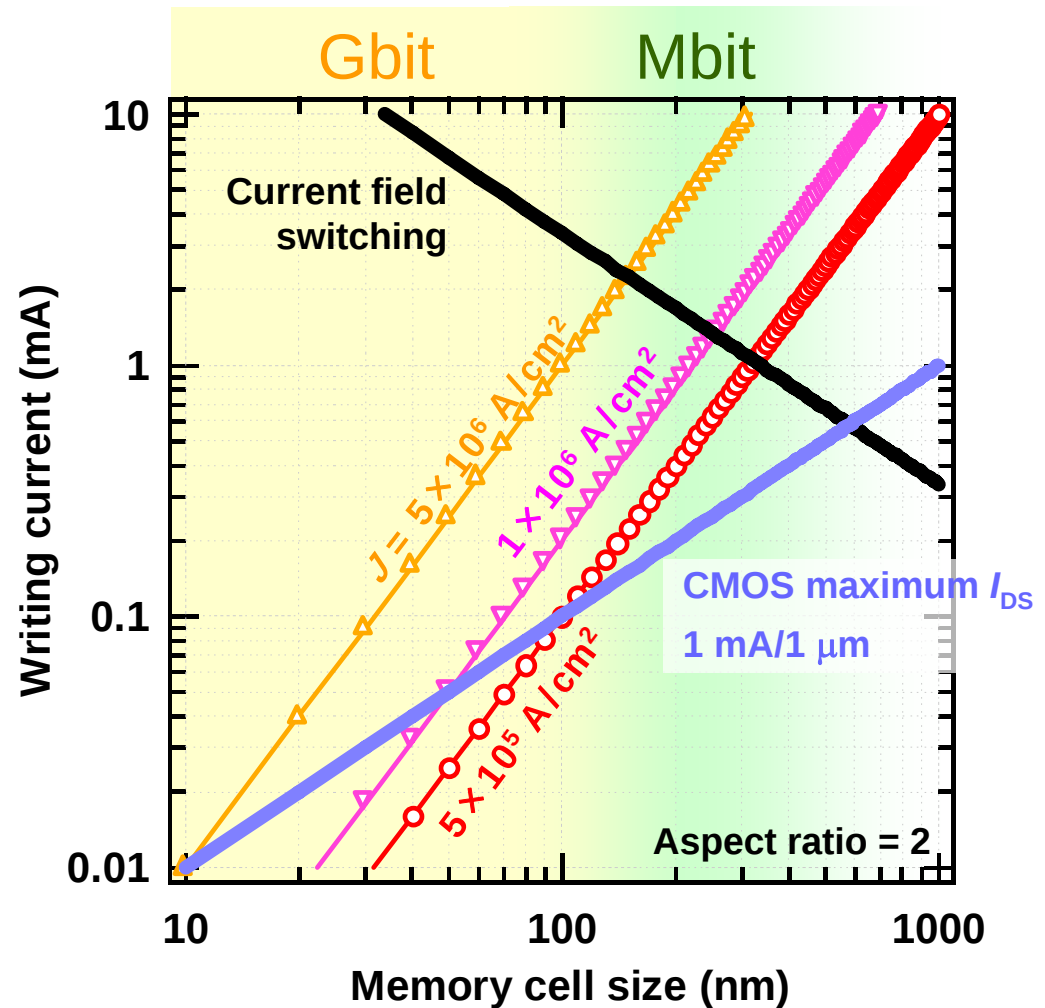
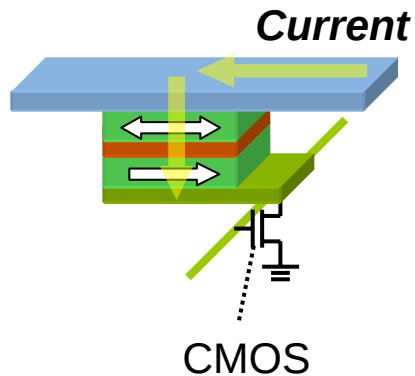
STS + TMR

G bit + low power MRAM
New devices



Issues for Spin-RAM

Spin transfer switching



Switching current : $J_{C0} \sim 5 \times 10^5 \text{ A/cm}^2$

Issues for device application

Requirement for devices

Junction Resis. 20 k Ω

Area 80 $\times$ 160 nm²

R $\cdot$ A $\sim$ 200 $\Omega\mu\text{m}^2$

$$J_{c0} \sim 5 \times 10^5 \text{ A/cm}^2$$

Switching current density

J. C. Slonczewski, JMMM159 (1996)L1 , PRB71(2005)024411

$$J_{c0}^{\pm} = \frac{\alpha e M_S d}{\mu_B g(P, \theta)} [H_{ext} \pm (H_{eff} + 2\pi M_S) / 2]$$

$$g_{tunnel}(P, \theta) = \frac{1}{2} \frac{P}{(1 + P^2 \cos \theta)}$$

Thermal stability

R. H. Koch, PRL92(2004)088302-1

$$J_c = J_{c0} \left\{ 1 - \frac{k_B T}{K_u V} \ln \frac{\tau_p}{\tau_0} \right\}$$

Pulse width

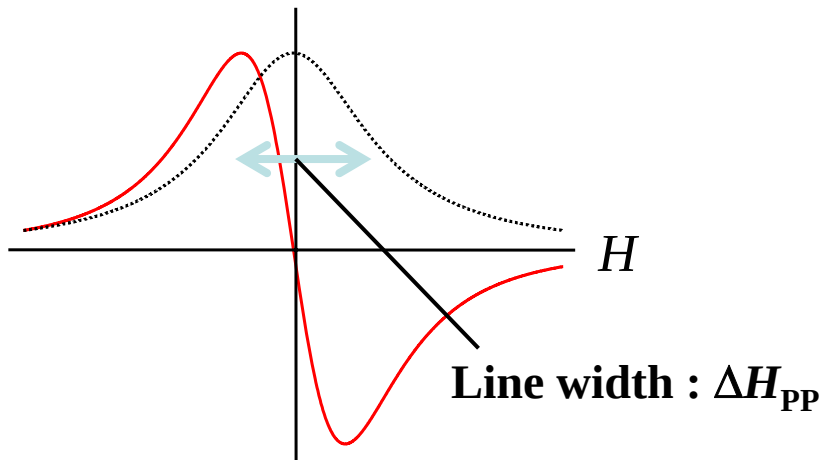
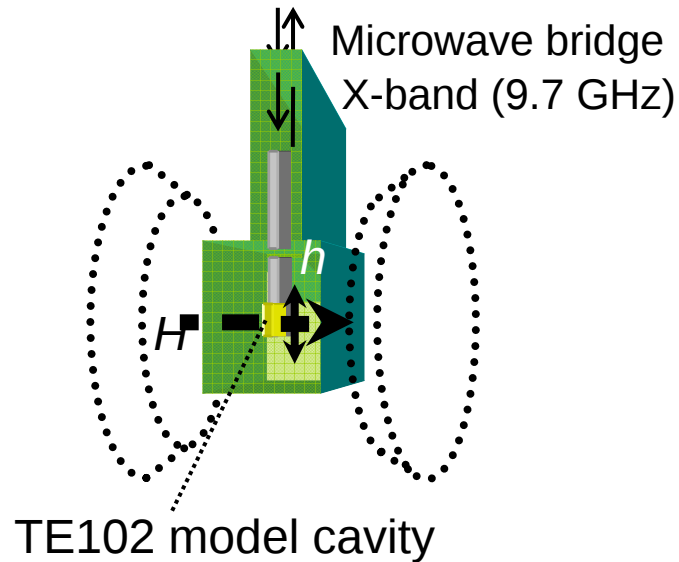
$$\tau_0 \sim 1 \text{ ns}$$

α : damping constant, M_s : saturation magnetization

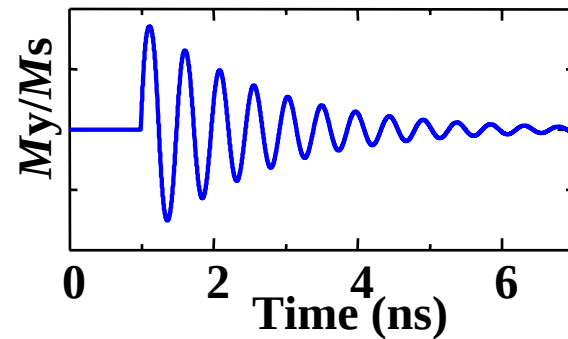
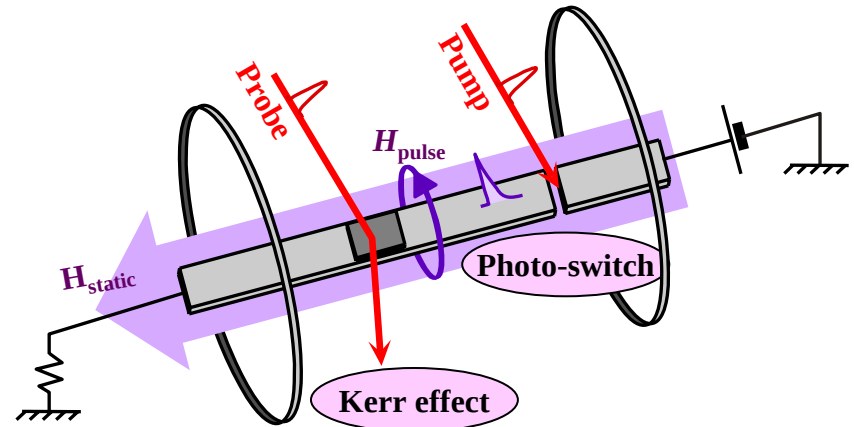
d : free layer thickness, P : spin polarization of pinned layer

Measurement of damping constant α

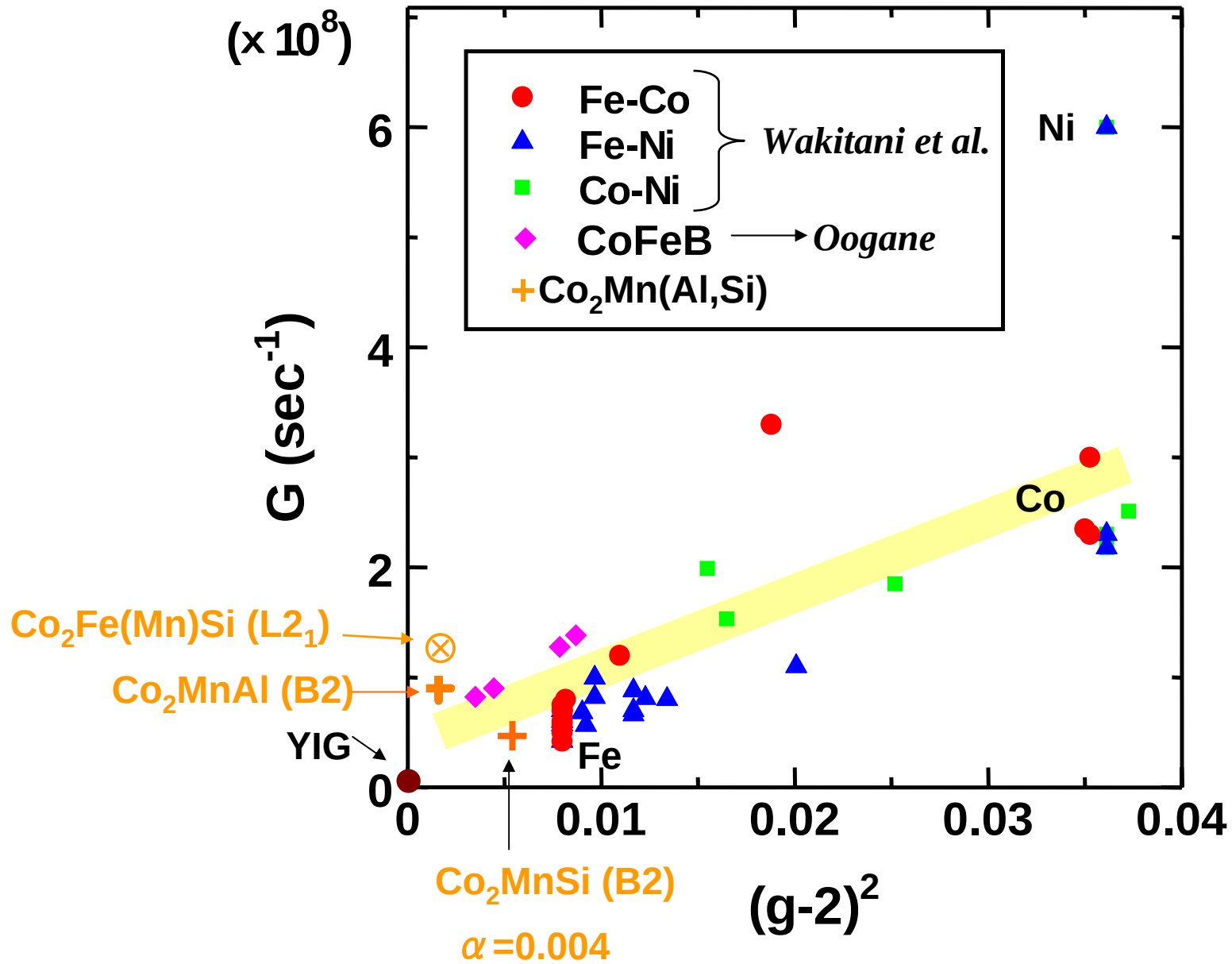
FMR



Pump-probe method



$$G \equiv \alpha \gamma M_s ; \quad G \propto (g-2)^2 ; \quad g-2 \approx L/S$$



Summary

- TMR ratio more than 100 % (200 %) at room temperature has been obtained for Heusler electrode and Al-O (MgO) barrier tunnel junctions.
- Damping constant α of Heusler alloys (Co_2MnSi) is 0.004.
- Rapid decrease of TMR ratio with raising temperature and increasing voltage can be explained by Non-quasiparticle states.
- Heusler alloys are excellent candidate for spintronics materials.

ACKNOWLEDGMENTS

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